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PATENT
Customer No. 22,852
Attorney Docket No. 07942.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Neal KUO

Serial No.: 09/900,165

Filed: July 9, 2001

For: METHOD AND SYSTEM FOR
DETERMINING THE BEST
INTEGRAL PROCESS PATH TO
PROCESS SEMICONDUCTOR
PRODUCTS TO IMPROVE YIELD

)
)
)
) Group Art Unit: 2825

)
) Examiner: Not yet assigned

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

REQUEST FOR APPROVAL OF DRAWING CHANGE

Subject to the approval of the Examiner, it is respectfully requested that Figure 5 of the above-captioned application be added to the Drawings.

Upon approval of the proposed changes, Applicants respectfully request that the submission of revised drawings be deferred until after a notice of allowance has issued.

Respectfully submitted,

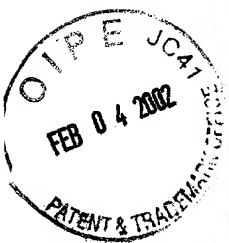
FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: February 4, 2002

By: Robert F. Rotella
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